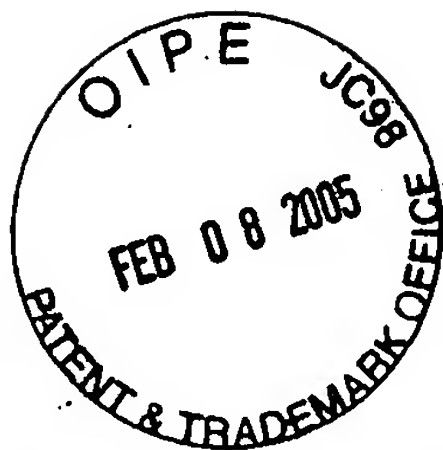


00862.023241



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Takehiko IWANAGA et al. ) : Examiner: Unassigned  
Application No.: 10/662,471 ) : Group Art Unit: Unassigned  
Filed: September 16, 2003 ) :  
For: POWER MONITORING UNIT, CONTROL ) December 2, 2003  
METHOD THEREFOR, AND EXPOSURE )  
APPARATUS )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION OF PRIORITY DOCUMENT

Sir:

In support of Applicants' claim for priority under 35 U.S.C. § 119, enclosed is one  
certified copy of the following foreign application:

JAPAN 2002-278113, filed September 24, 2002.

Applicants' undersigned attorney may be reached in our Washington, D.C., office by  
telephone at (202) 530-1010. All correspondence should continue to be directed to our address  
given below.

Respectfully submitted,

Attorney for Applicants  
Steven E. Warner  
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200  
SEW/eab

日本国特許庁  
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されて  
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed  
with this Office.

出願年月日 2002年 9月24日  
Date of Application:

出願番号 特願2002-278113  
Application Number:

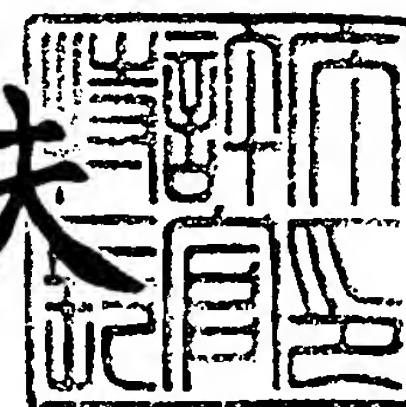
ST. 10/C]: [JP 2002-278113]

願 人 キヤノン株式会社  
Applicant(s):

2003年10月14日

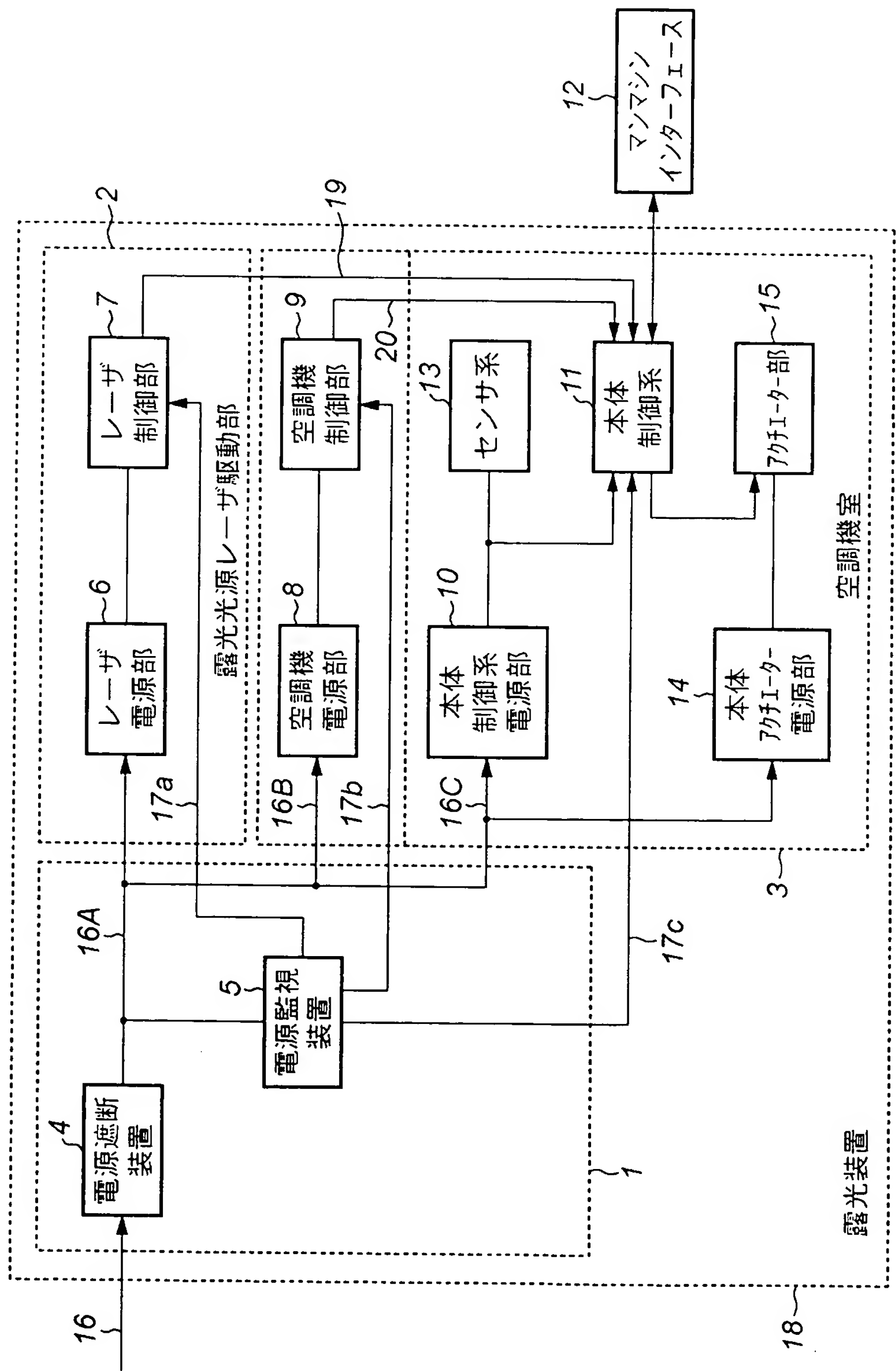
特許庁長官  
Commissioner,  
Japan Patent Office

今井康夫

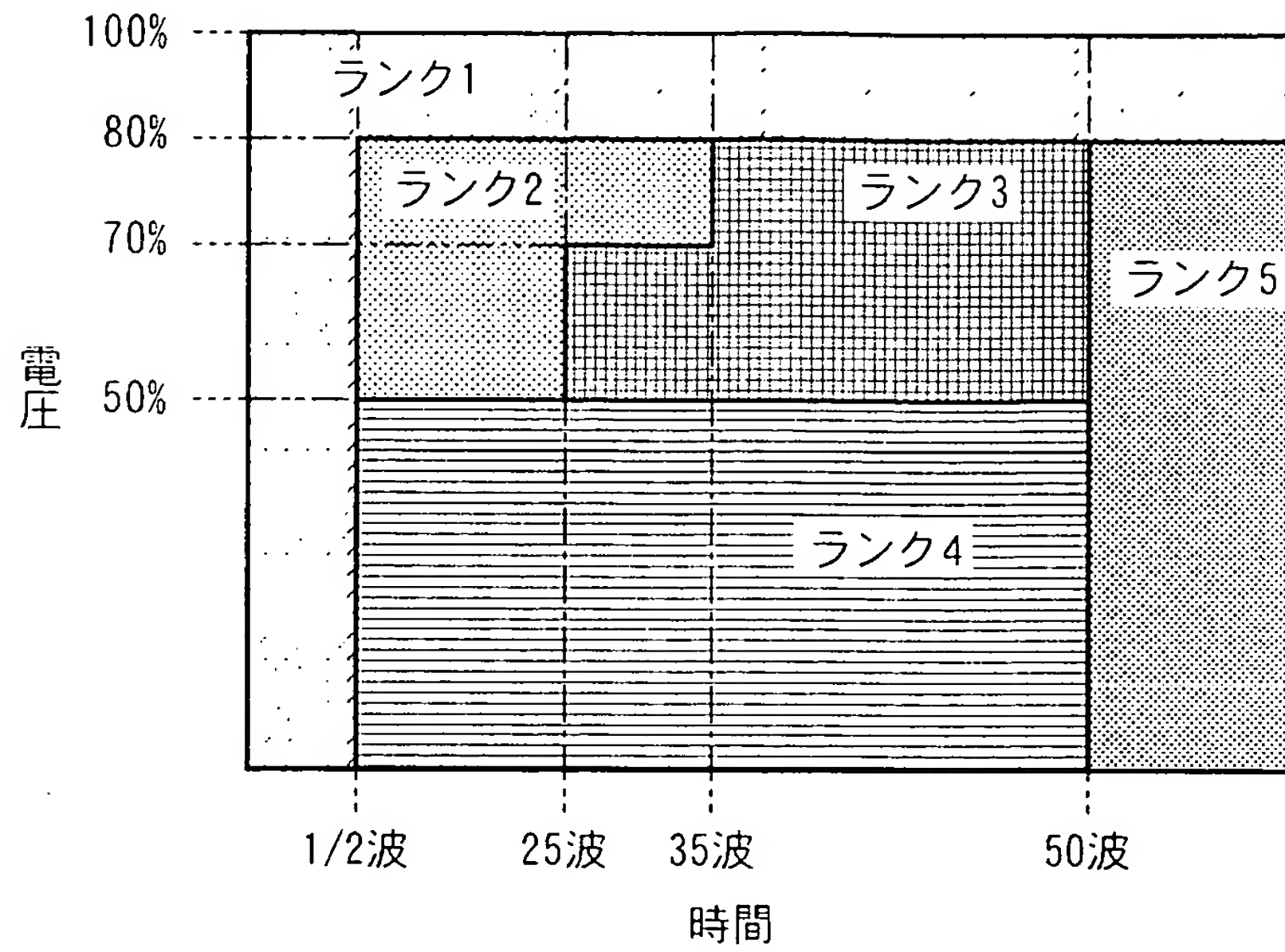


【書類名】 図面

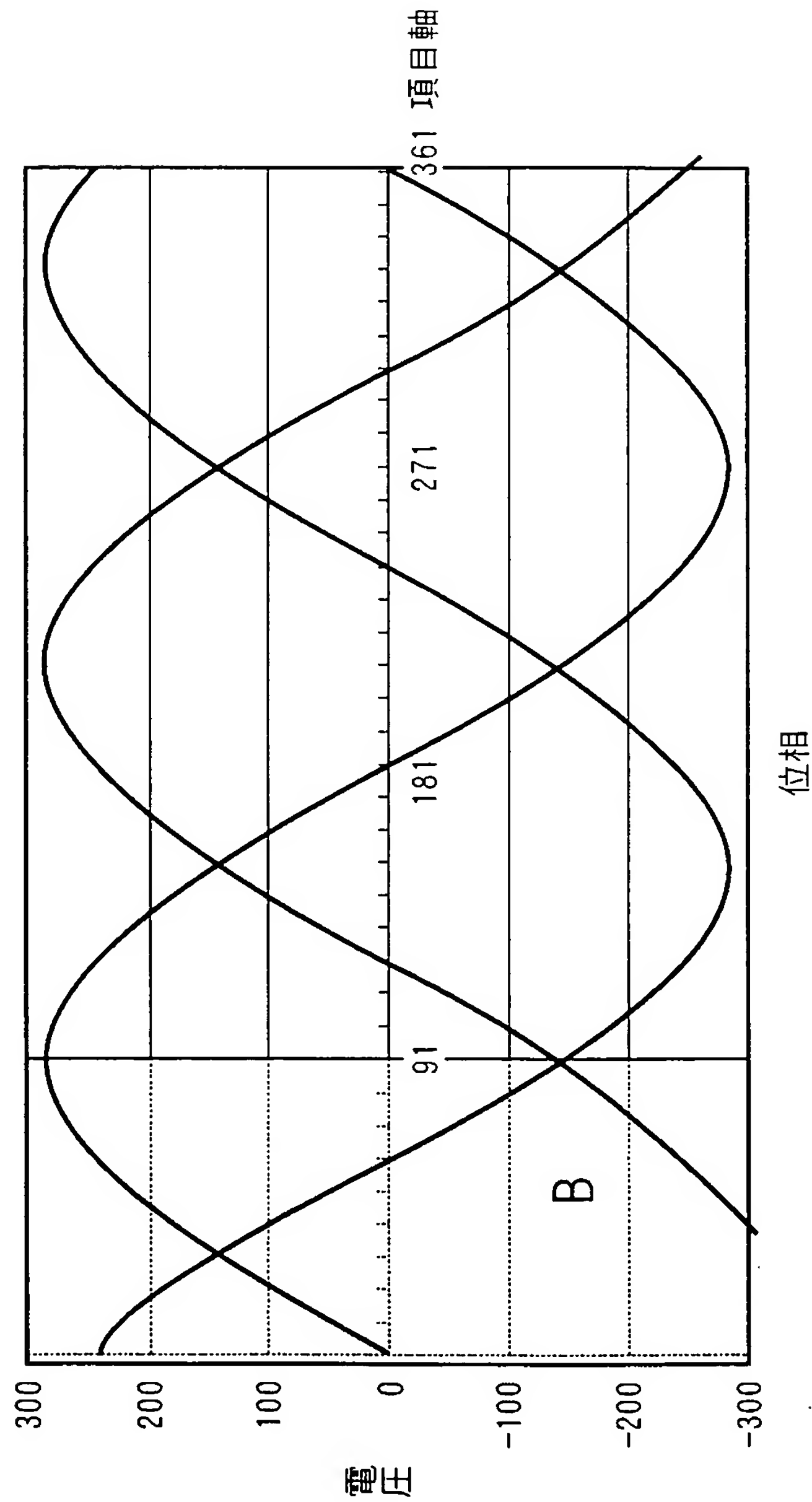
【図 1】



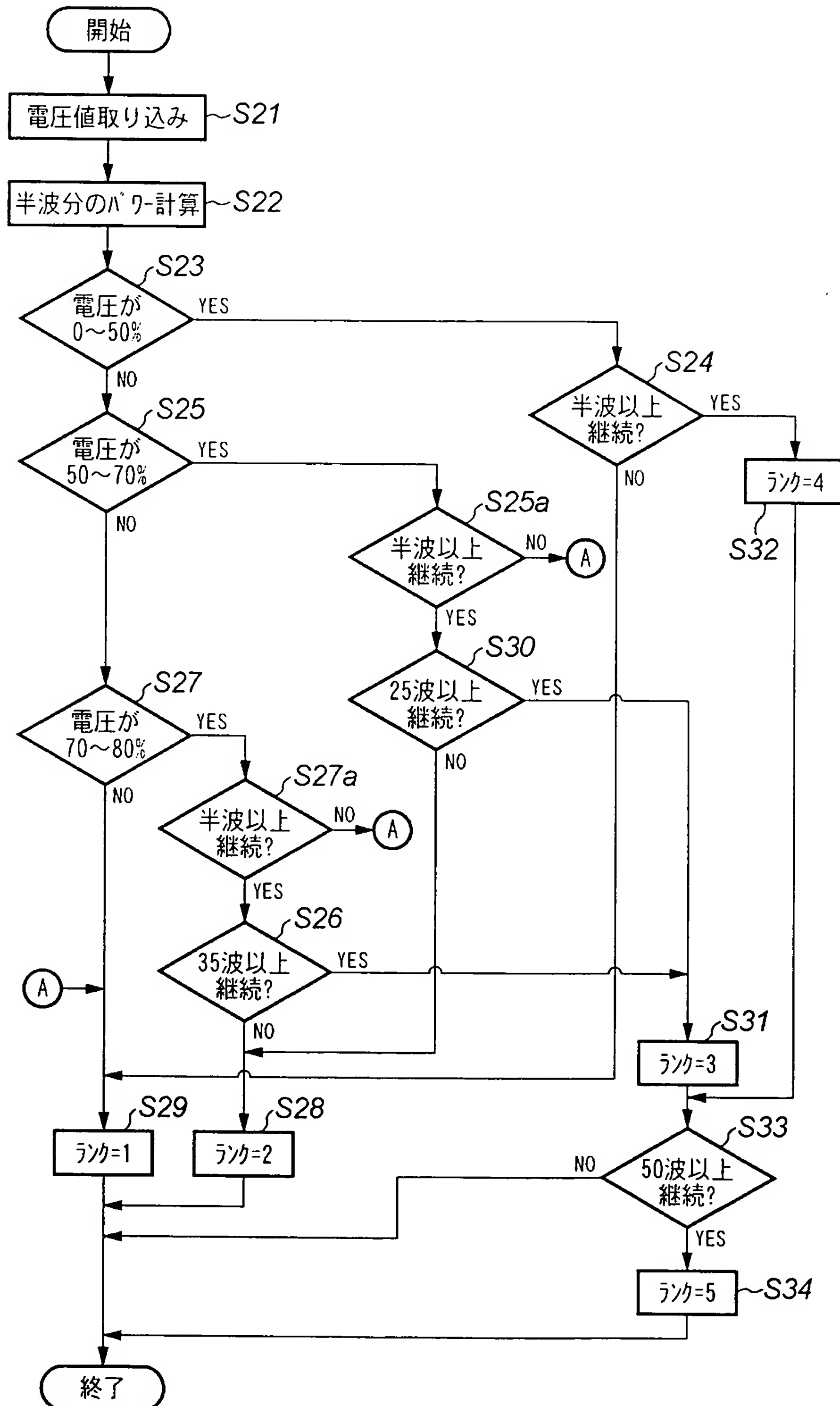
【図 2】



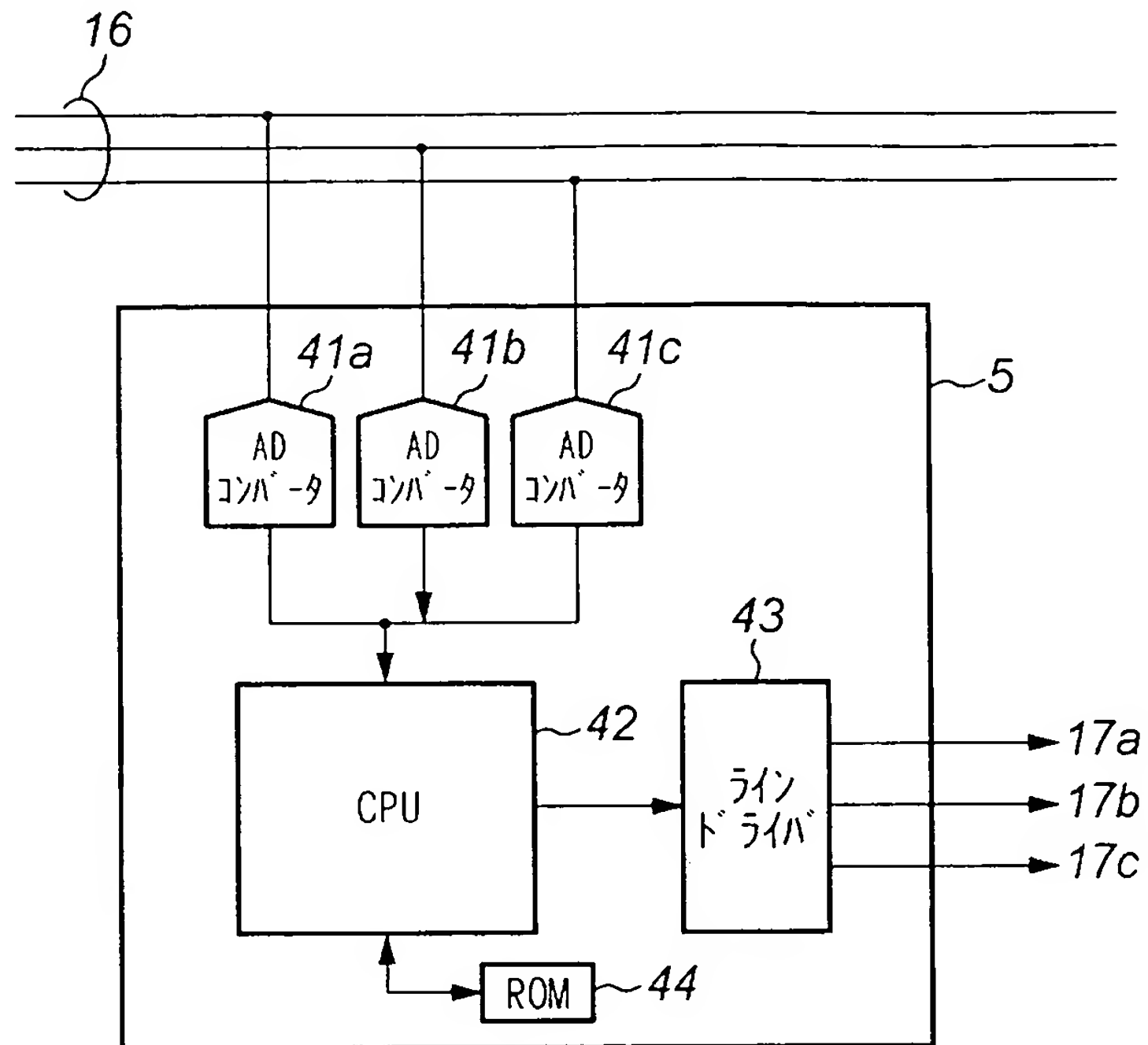
【図 3】



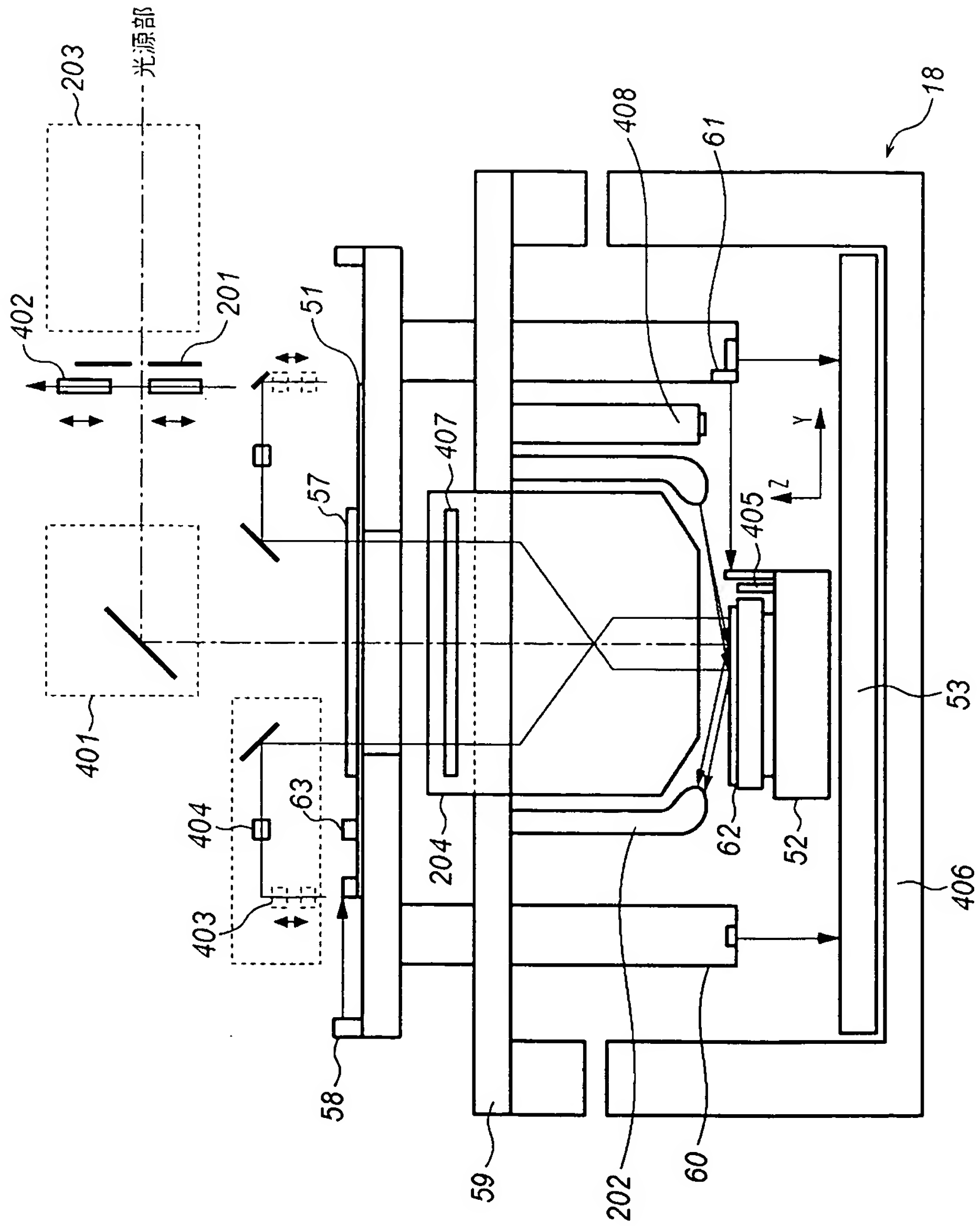
【図 4】



【図 5】

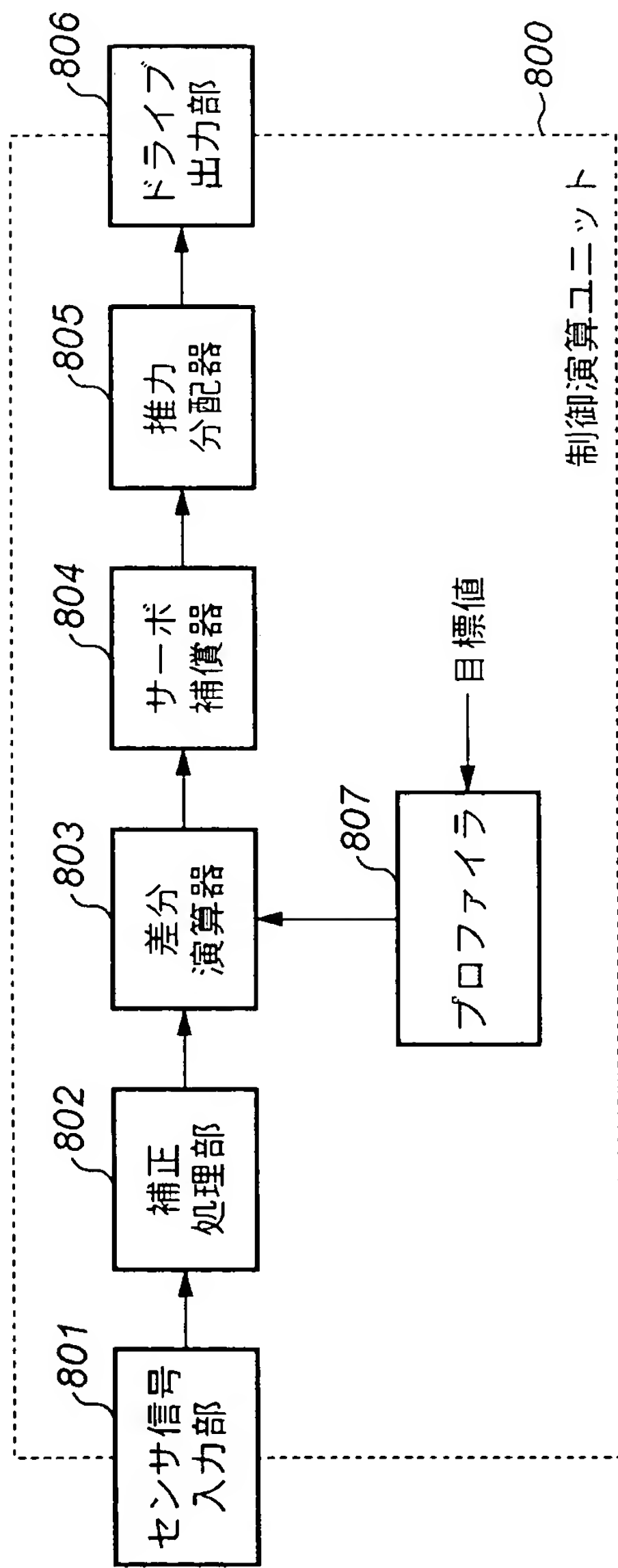


【図 6】

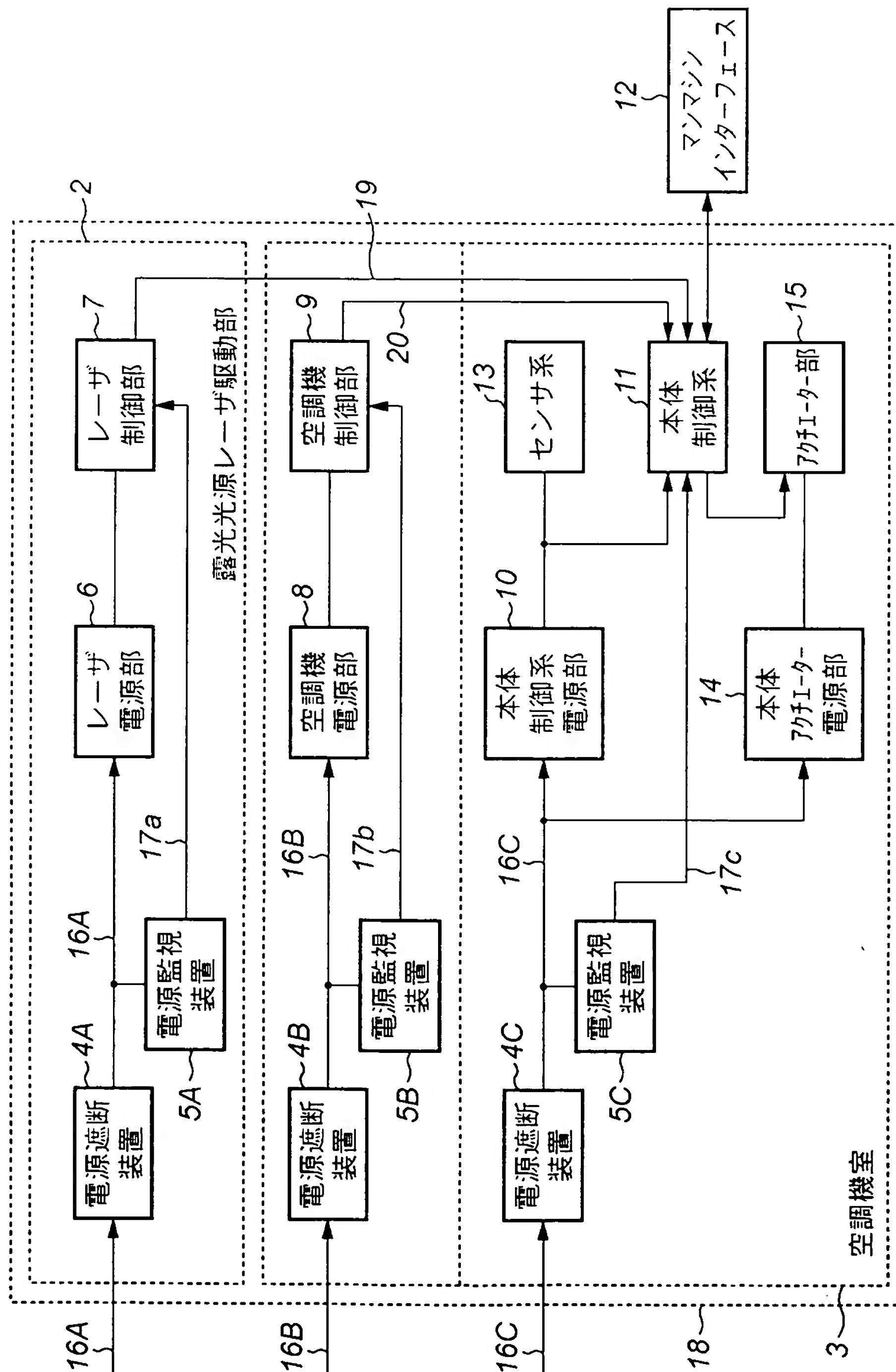




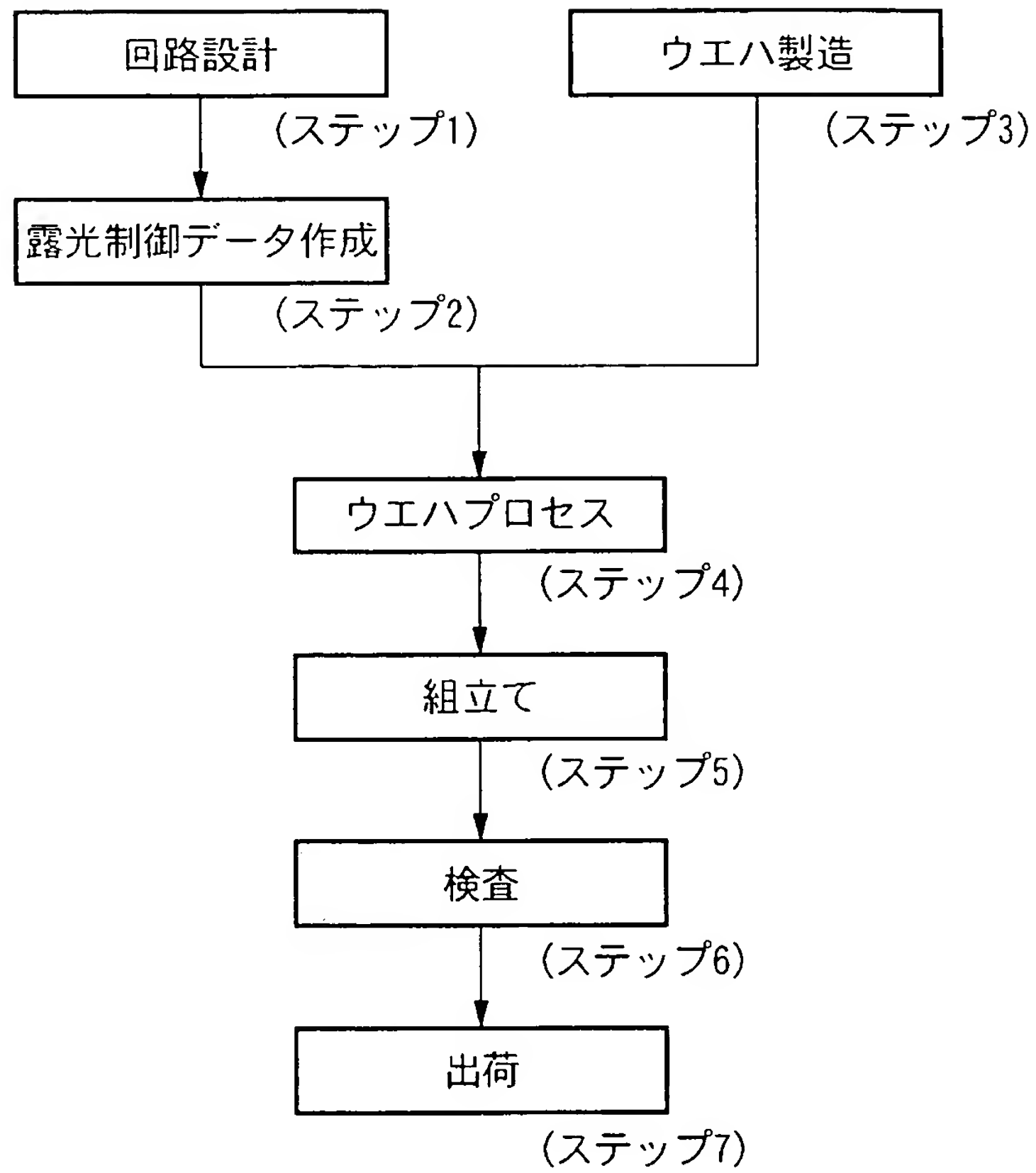
【図 7】



【図8】



【図 9】



【図 10】

